

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/643,717	<b>Applicant(s)/Patent under Reexamination</b> YANAGISAWA, SATOSHI
	<b>Examiner</b> Leonardo Andújar	<b>Art Unit</b> 2826

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner